

Docket No.: 49677-107

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Toshihiro OOISHI, et al.

Serial No.:

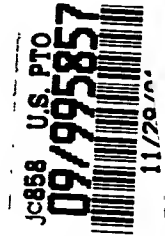
Filed: November 29, 2001

For: METHOD OF PRODUCING GLASS PARTICLES DEPOSIT

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Group Art Unit:

Examiner:



**CLAIM OF PRIORITY**

Commissioner for Patents  
Washington, DC 20231

Sir:

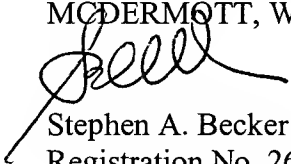
In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

**Japanese Patent Application No. 2000-362829, filed November 29, 2000**

A certified copy will be filed in due course.

Respectfully submitted,

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